



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of
Shunpei YAMAZAKI et al.
Serial No. 09/837,877
Filed: April 19, 2001
For: Semiconductor Device

VERIFICATION OF TRANSLATION

Honorable commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

I, Kazuya Morikawa, Flat SEL A105, 304-1, Hase, Atsugi-shi, Kanagawa-ken, 243-0036, Japan, declare:

that I am well acquainted with both the Japanese and English languages; and
that to best of my knowledge and belief the following is a true and correct translation of
Japanese Patent Application No. 10-374878 filed on December 28, 1998.

I further declare that all statements made herein of my own knowledge are true and that
all statements are made on information and belief are believed to be true; and further that these
statements were made with the knowledge that willful false statements and the like so made
are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United
States Code, and that such willful false statements may jeopardize the validity of the
application or any patent issuing thereon.

Date: this 3rd day of August, 2001



Name: Kazuya Morikawa

[Name of Document] Patent Application

[Reference Number] P004066-06

[Filing Date] December 28, 1998

[Attention] Commissioner, Patent Office

[International Patent Classification] H01L 21/00

[Title of Invention] SEMICONDUCTOR DEVICE

[The Number of Claims] 18

[Inventor]

[Address] 398, Hase, Atsugi-shi, Kanagawa-ken
c/o Semiconductor Energy Laboratory Co., Ltd.

[Name] Shunpei YAMAZAKI

[Inventor]

[Address] 398, Hase, Atsugi-shi, Kanagawa-ken
c/o Semiconductor Energy Laboratory Co., Ltd.

[Name] Yu YAMAZAKI

[Inventor]

[Address] 398, Hase, Atsugi-shi, Kanagawa-ken
c/o Semiconductor Energy Laboratory Co., Ltd.

[Name] Jun KOYAMA

[Inventor]

[Address] 398, Hase, Atsugi-shi, Kanagawa-ken
c/o Semiconductor Energy Laboratory Co., Ltd.

[Name] Takayuki IKEDA

[Inventor]

[Address] 398, Hase, Atsugi-shi, Kanagawa-ken
c/o Semiconductor Energy Laboratory Co., Ltd.

[Name] Hiroshi SHIBATA

[Inventor]

[Address] 398, Hase, Atsugi-shi, Kanagawa-ken
c/o Semiconductor Energy Laboratory Co., Ltd.

[Name] Hidehito KITAKADO

[Inventor]

[Address] 398, Hase, Atsugi-shi, Kanagawa-ken
c/o Semiconductor Energy Laboratory Co., Ltd.

[Name] Takeshi FUKUNAGA

[Applicant]

[Identification Number] 000153878

[Name] Semiconductor Energy Laboratory Co., Ltd.

[Representative] Shunpei YAMAZAKI

[Indication of Handlings]

[Number of Prepayment Note] 002543

[Payment Amount] 21000

[List of Attachment]

[Attachment] Specification 1

[Attachment] Drawing 1

[Attachment] Abstract 1

[Proof] required